

**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800**

Attorney's Docket No.: 42P17764

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Alejandro Hurtado

Application No.: **10/769,534**

Filed: **January 30, 2004**

For: **MOUNTING AND DICING PROCESS
FOR WAFERS**

Examiner: **Ha, Nathan W.**

Art Unit: **2814**

Confirmation No.: **8641**

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P. O. 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed November 13, 2006, Applicant respectfully requests entry of the following amendments.